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501.39983X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: NABATAME et al

Serial No.: 09/806,861

Filed: April 5, 2001

For: Semiconductor Device And Manufacturing Method Thereof

Art Unit: 2812

Examiner: J. Kennedy

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97 & 1.98

Mail Stop: DD
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 13, 2003

Sir:

In the matter of the above-identified application, applicants are submitting herewith a copy of a communication from a foreign patent office in a counterpart foreign application and copies of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

This information disclosure statement is being submitted before the mailing date of either a final action or a notice of allowance and is accompanied by the fee of \$180.00 set forth in 37 CFR 1.17(p).

To the extent the documents listed on the attached form equivalent to Form PTO-1449 are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by computer generated translations.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 501.39983X00) and please credit any excess fees to such deposit account.

Respectfully submitted,

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